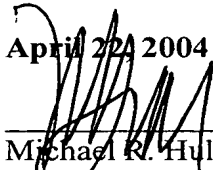




PATENT
29936/39461

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Seung Woo Shin and Cha Deok Dong)	I hereby certify that this paper is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on this date:
Serial No.: 10/631,362)	
Filed: July 31, 2003)	
For: Method of Forming Oxynitride Film)	
Group Art Unit: 2812)	April 22, 2004
Examiner: Alexander G. Ghyka)	 _____ Michael R. Hull Registration No. 35,902 Attorney for Applicants

COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

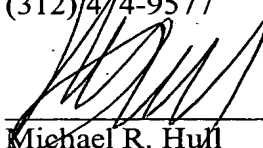
Sir:

In addition to the reasons for allowance set forth in the allowance papers that were mailed in connection with the present application, it is respectfully submitted that the claims are allowable for the additional reasons that the invention defined by the language of the claims is neither anticipated by, nor would have been obvious when taken as a whole in view of, the art of record.

Respectfully submitted,

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April 22, 2004